

Notice of References Cited

Application/Control No.

10/714,816

Applicant(s)/Patent Under
Reexamination
TASHIRO ET AL.

Examiner

LUCY P. CHIEN

Art Unit

2871

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,141,075	10-2000	Ohmuro et al.	349/130
	B	US-			
	C	US-			
	D	US-			
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	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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